ttorney's Docket No.: 042390P3955D

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
Andideh, Ebrahim et al.))
U.S. Serial No: 09/436,092) Examiner: McDonald, Shantese L.
Filed: November 8, 1999) Art Unit: 3723
For: POLISH PAD WITH NON-UNIFORM GROOVE DEPTH TO IMPROVE WAFER POLISH RATE UNIFORMITY))) _)
Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450	

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action that was mailed on March 11, 2005. Applicants respectfully request the Examiner to enter the following amendments and consider the remarks therein.

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